

<b>Notice of References Cited</b>	Application/Control No. 10/521,242	Applicant(s)/Patent Under Reexamination OGAWA, MIKI	
	Examiner NATHAN H. EMPIE	Art Unit 1712	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
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**FOREIGN PATENT DOCUMENTS**

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	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Crepaldi et al. "Design and Post-Functionalisation of Ordered Mesoporous Zirconia Thin Films" Chemical Communications, 2001, pg 1582-1583.
	V	Miyata et al "Preparation of Highly Ordered Mesostructured Tin Oxide Film with a Microcrystalline Framework through Vapor-Induced Liquid Crystal Templating" in Chem. Mater. 2003, 15, 1334-1343; available online 2/28/03.
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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